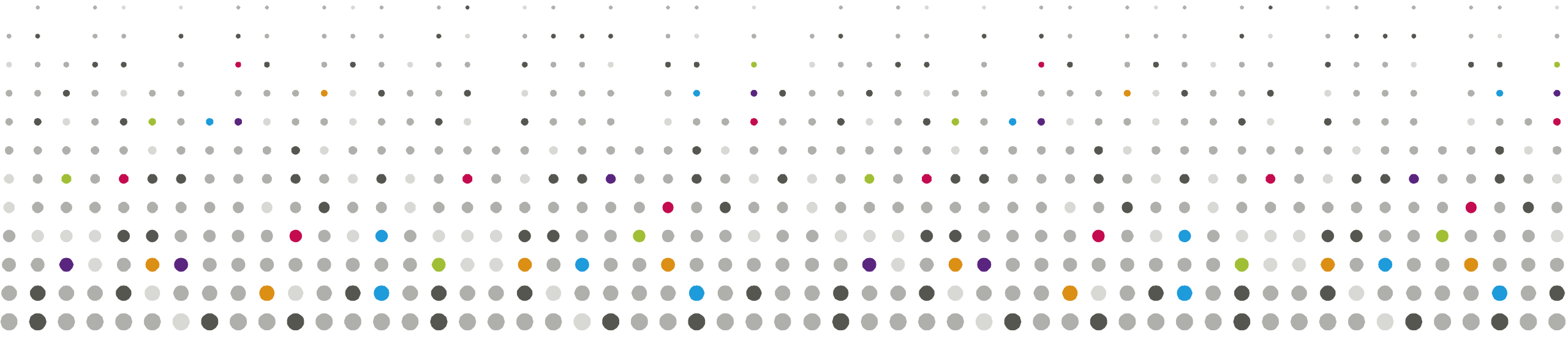


The Mycronic path back to Semiconductors and into Deep Learning

Thomas Kurian, Feb 25th 2020



Mycronic enabling manufacturing of products for every day life



By producing equipment for advanced manufacturing of electrical products



Business area PG
Mask writers & metrology



Business area AS
Assembly equipment

Mycronic in short



40

years of experience in
innovation

1300

employees
in ten countries

50

Mycronic is represented
in more than
50 countries

500

patents proves the power
of innovation.

3,000

customers use production
equipment from
Mycronic

98%

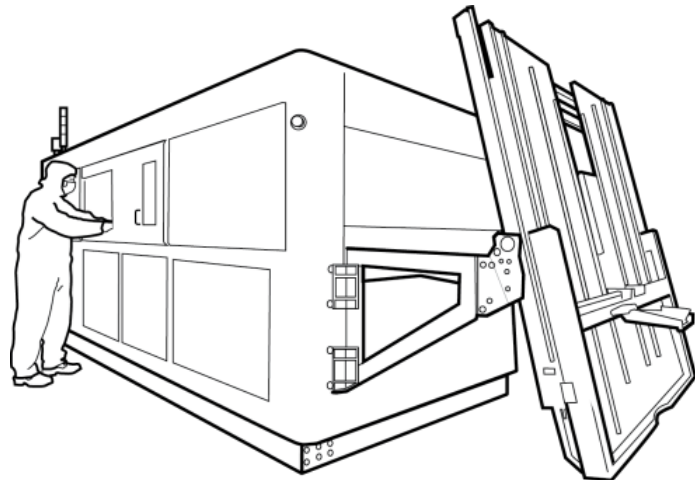
of consolidated
net sales are
exports

Display production using photomasks

Lithography a capital intensive process but highly cost effective

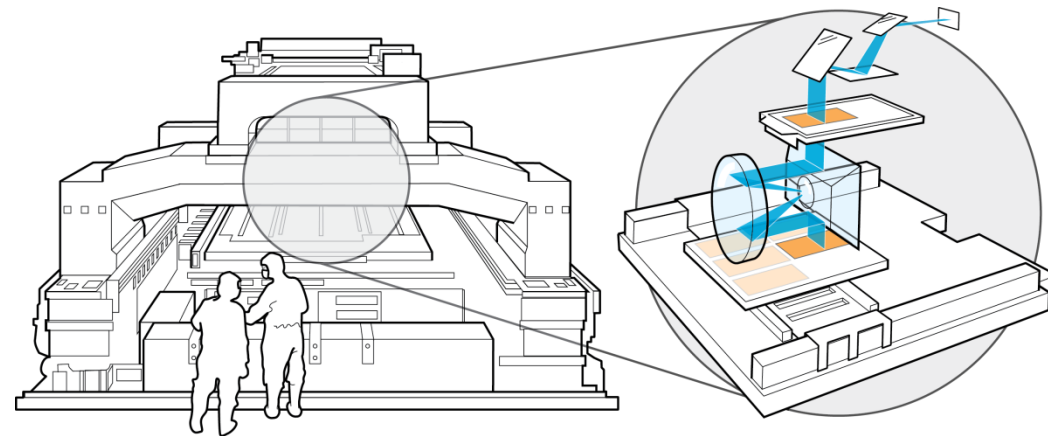
~ 100,000
times faster
than your
high speed
broad band

Mask writer – writes the photomask



- 24-48 hours writing time
- ~25 Terabyte data
- Transfer rate ~1.2-2.5 Gbit/s

Aligner – copies the photomask



- ~20 seconds to copy the photomask
- ~25 Terabyte data
- Transfer rate ~10 Tbit/s

Lithography using photomasks is the only technology used today in mass production to create high end electronics and high end display TFT back planes

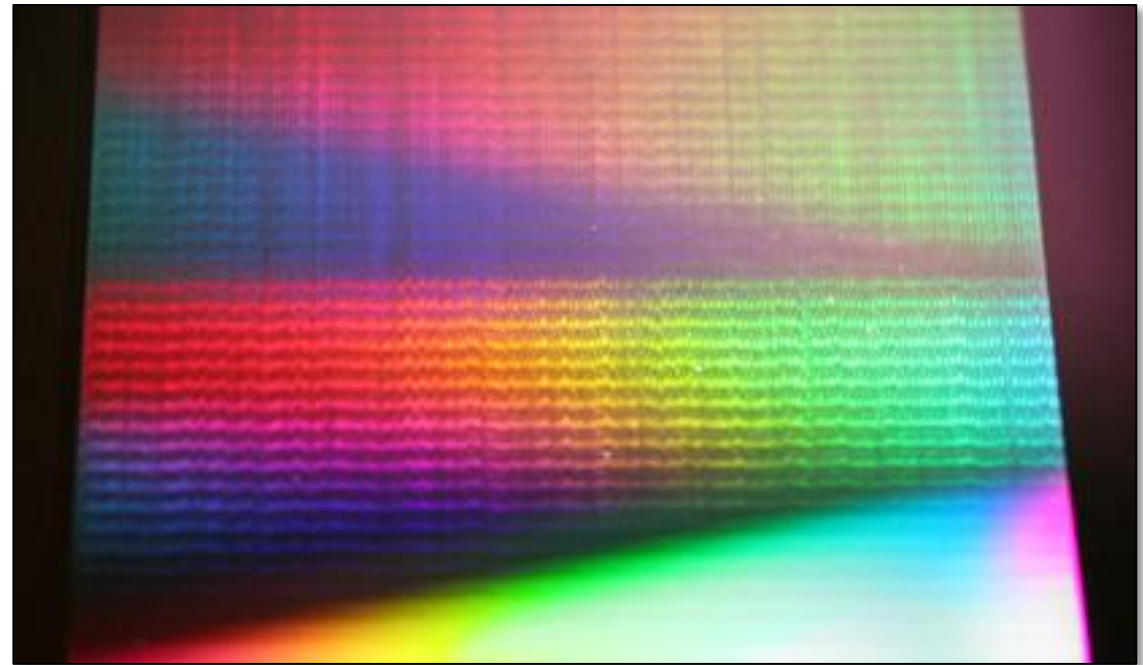
Mycronic has a unique position as the sole supplier of mask writers to the display industry

Can handle photomasks up to 1.8 x 2.0 m



Photo: Courtesy of SKE Electronics

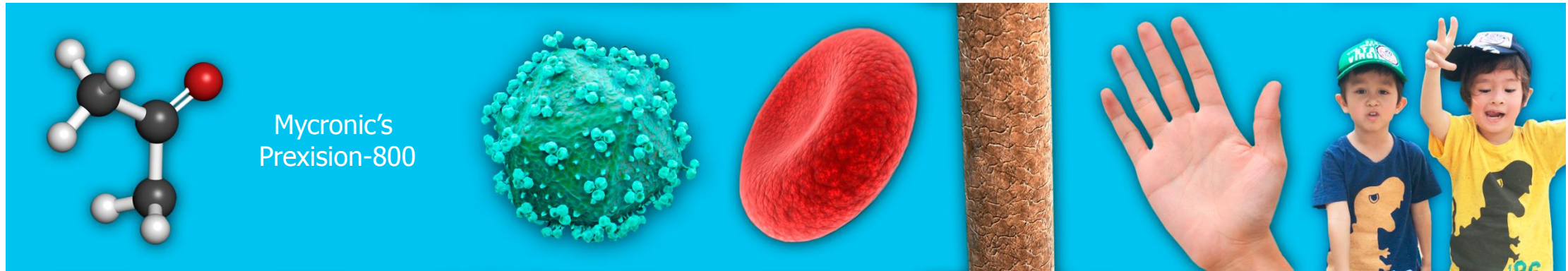
"The mura (斑) challenge"
- Japanese word meaning irregularity



....So literally you could say that all mass produced high end displays in the world has a connection to Mycronic...

Mycronic mask writers

Offering nanometer precision



Mycronic's
Precision-800

1 ångström

1 nanometer

100 nanometer

10 micrometer

100 micrometer

10 cm

1 meter

Atom

Virus

Red blood cell

Hair

Hand

Child



Mycronic's Precision-800 delivers nanometer precision

Display trends in favor for the photomask industry

Transition from LCD to AMOLED



→ Drives mask complexity

Larger and larger displays



→ Drives mask size

Higher and higher resolution



~60 PPI

~160 PPI

~400 PPI

→ Drives mask complexity

Displays in new applications



→ Drives additional demand & new requirements

The new SLX Series

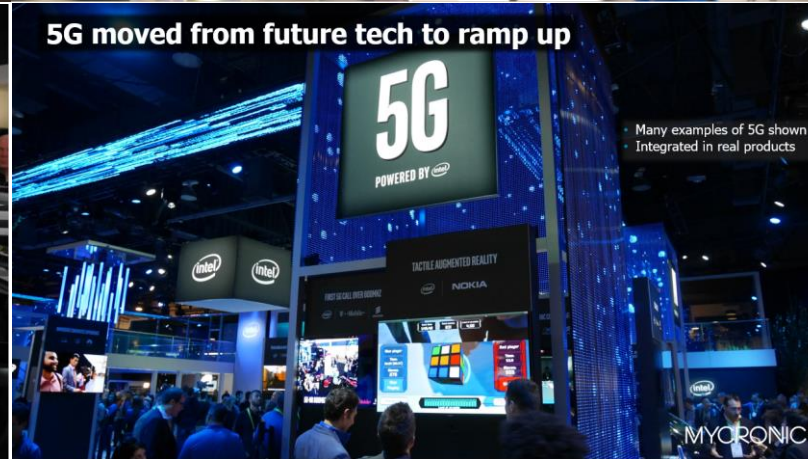
The laser mask writer for tomorrow's semiconductor market



MYCRONIC

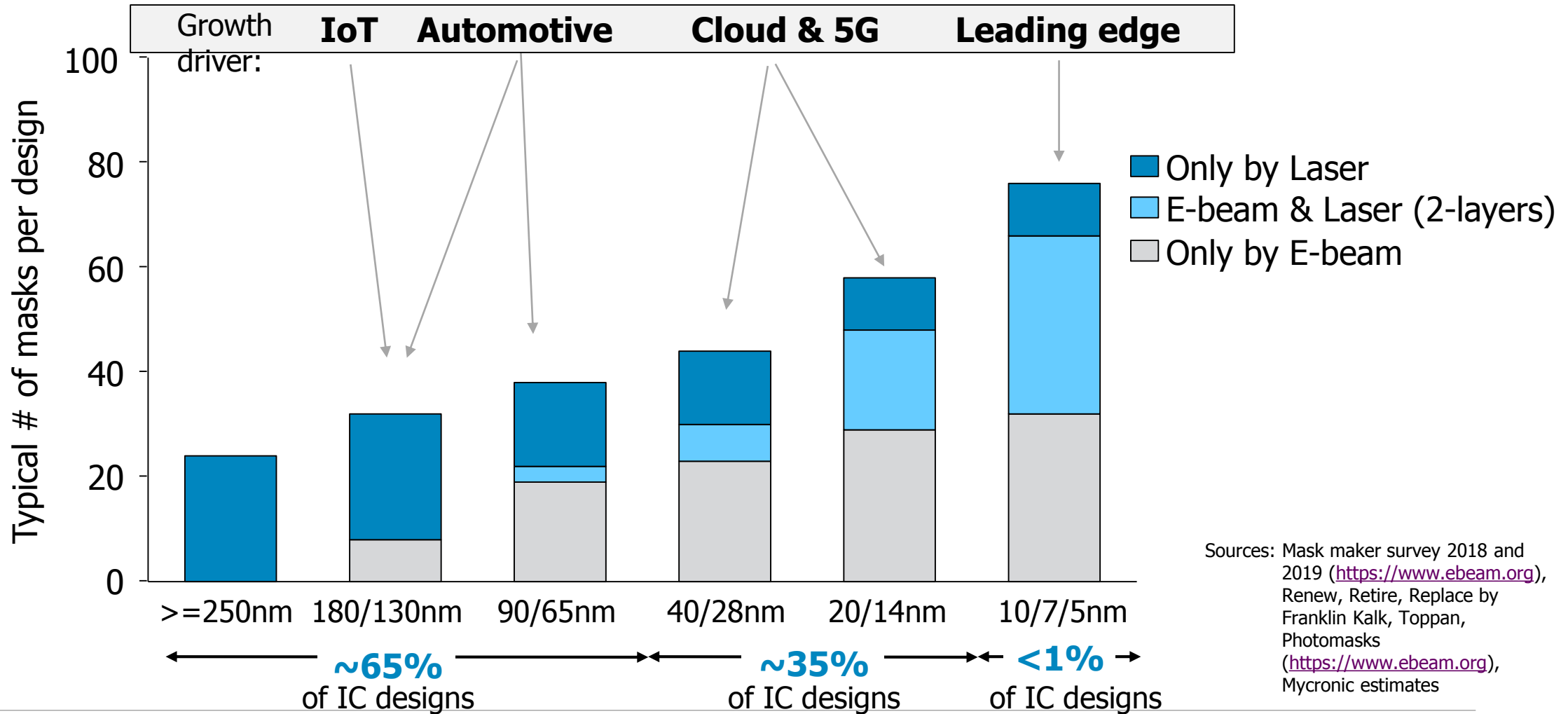
The electrification of everything

More devices will need processing power to keep up with the pace of change



Laser writer demand on the rise

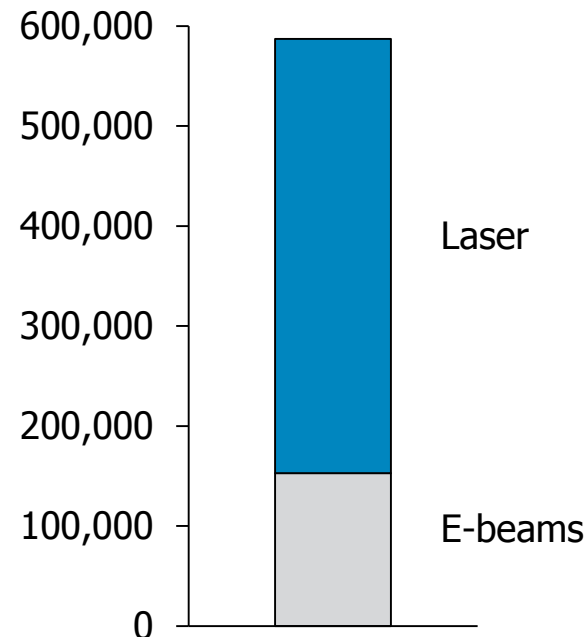
Additional demand driven by both market trends and technology trends



Laser writer demand on the rise

Additional demand driven by both market trends and technology trends

Semiconductor masks produced

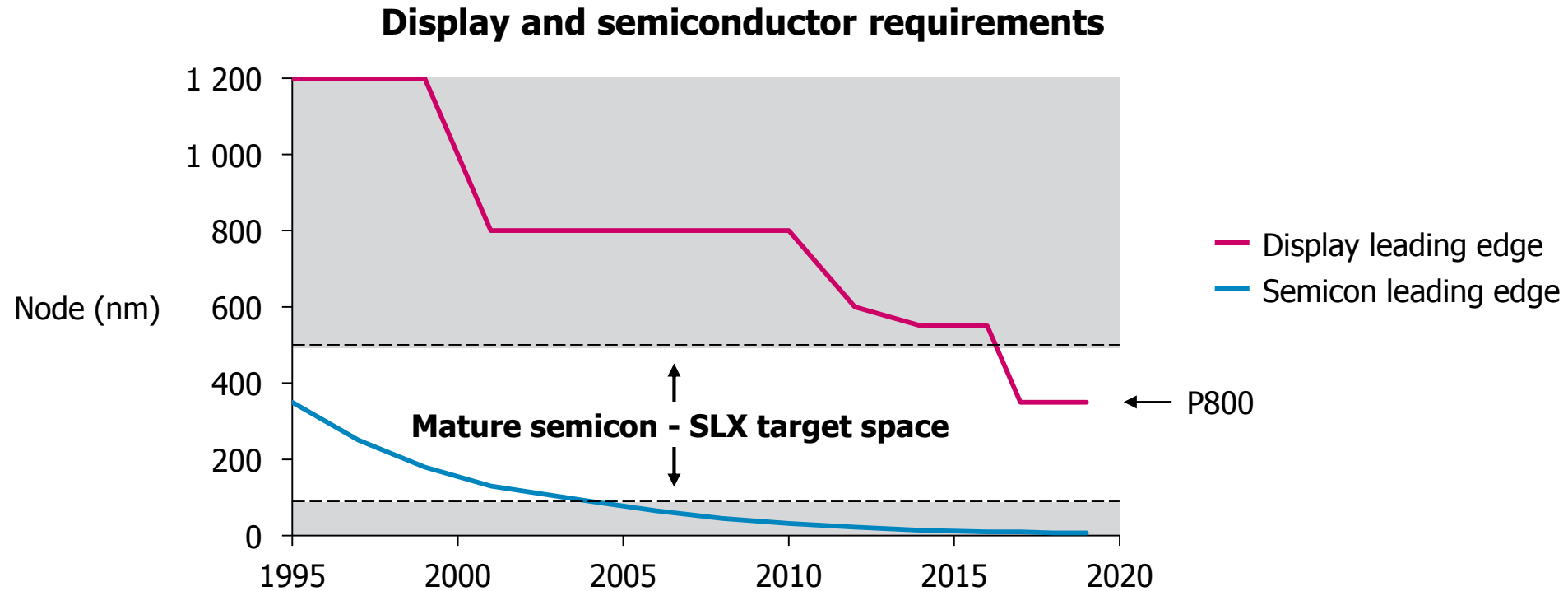


- Around 600 000 photomasks enable the semicon industry today
- 70-75% of these masks are written by laser

Sources: Mask maker survey 2018 (<https://www.ebeam.org>), Mycronic estimates

In excellent position to capture the opportunity

Leveraging existing display technology and customer relationships



Despite competition in segment our ambition is to capture a majority of the upcoming opportunity with the SLX-series and over time establish a strong presence in the mature semicon segment

The SLX value proposition

**Lowest cost
per mask**

“Superior writing
speed and low
running cost”

**Reliable and
stable
operation**

“Field proven
technology and
strong service
organization”

**A long term
committed
supplier**

“Modern platform
with future
development
possibilities”

**Best overall
investment**

“Attractive entry
price and many
options to enable
a cost efficient
production”

Born to run

(first shipment expected year end 2020/21)

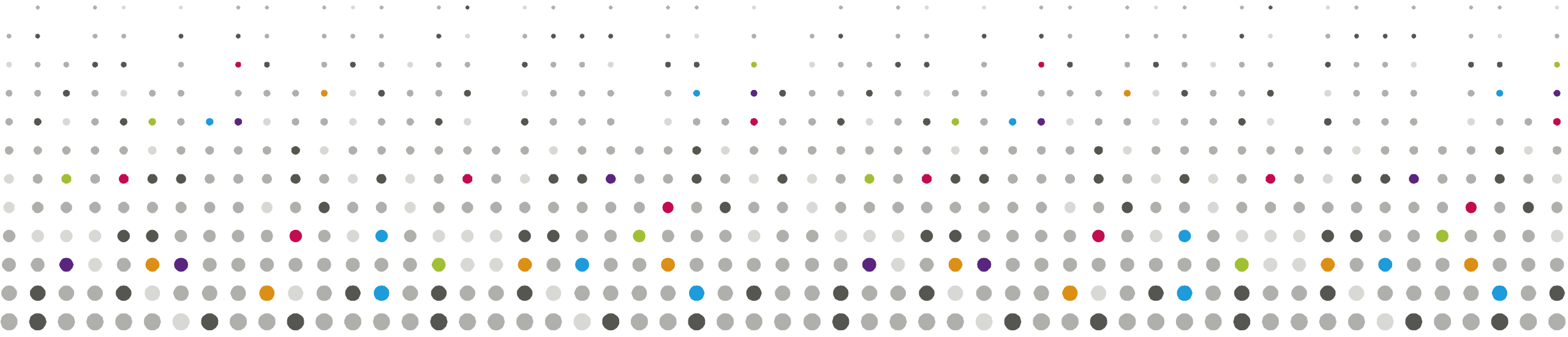
The new SLX Series

The laser mask writer for tomorrow's semiconductor market

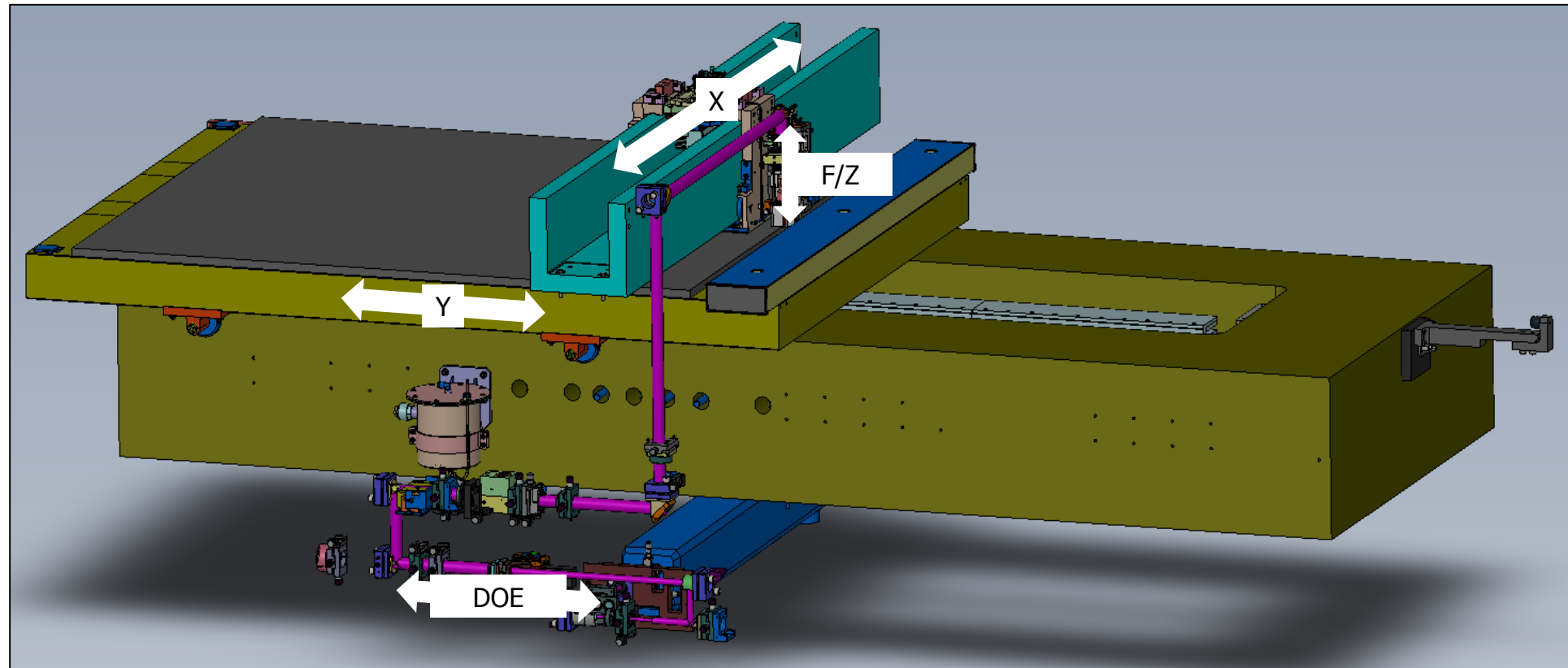


- Available in different configurations
- Writing times from 20 minutes
- Meets requirements down to 90 nm node

Applying Deep Learning Methodologies to Improve Mask Shop Operation

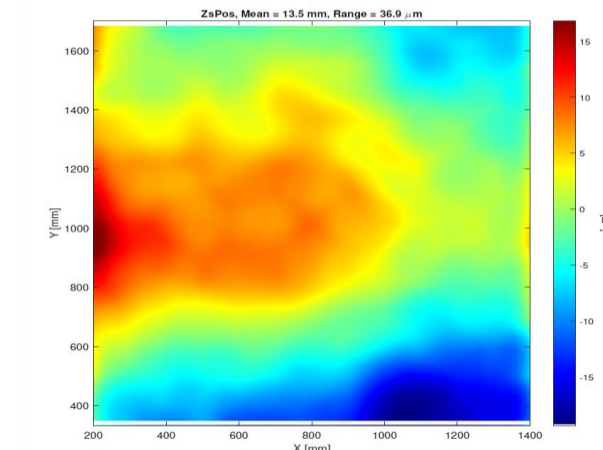
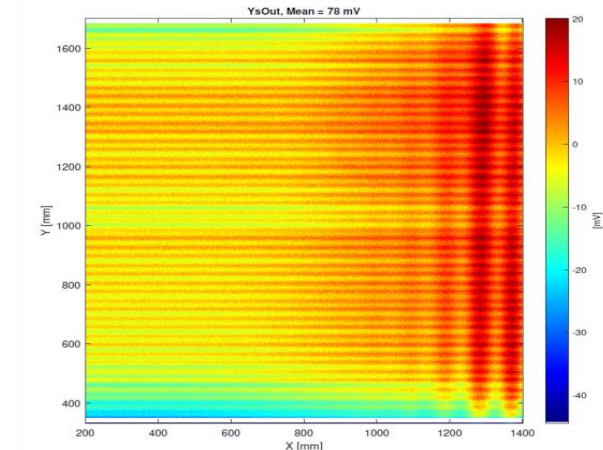
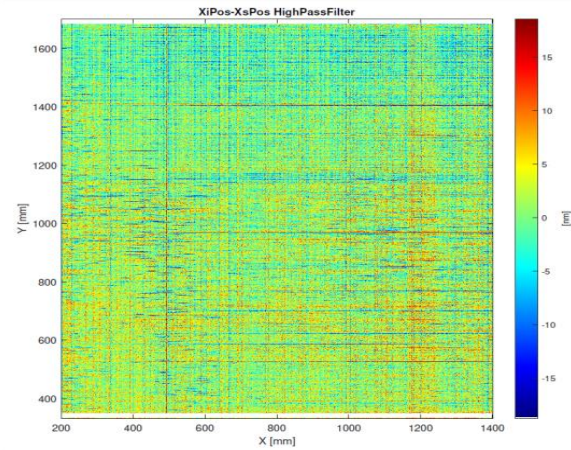
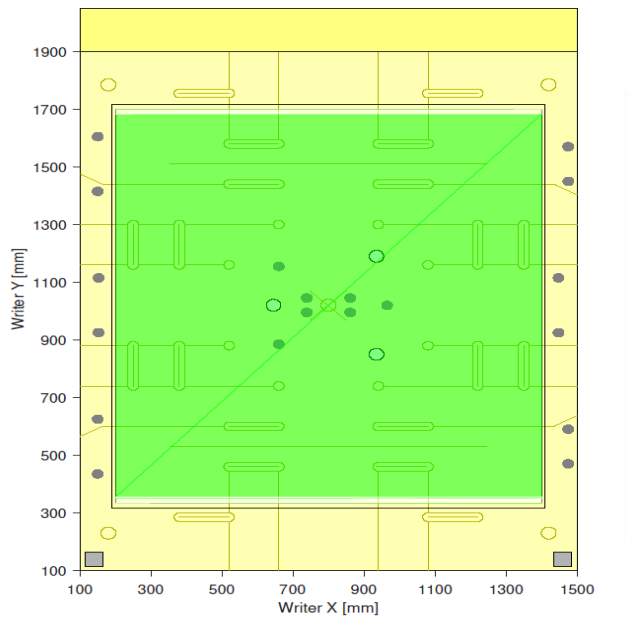


Logging of Writer Servo Data



Writer Servo Log Visualization

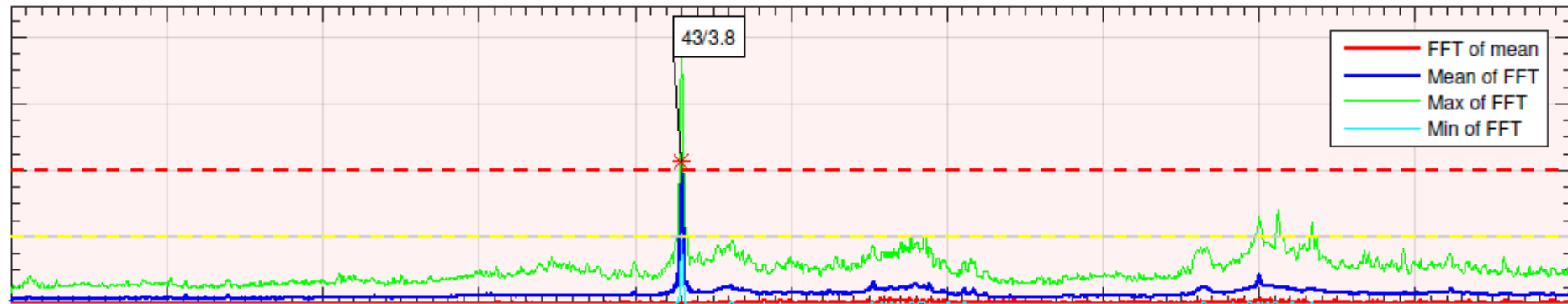
Looking for mura in the data



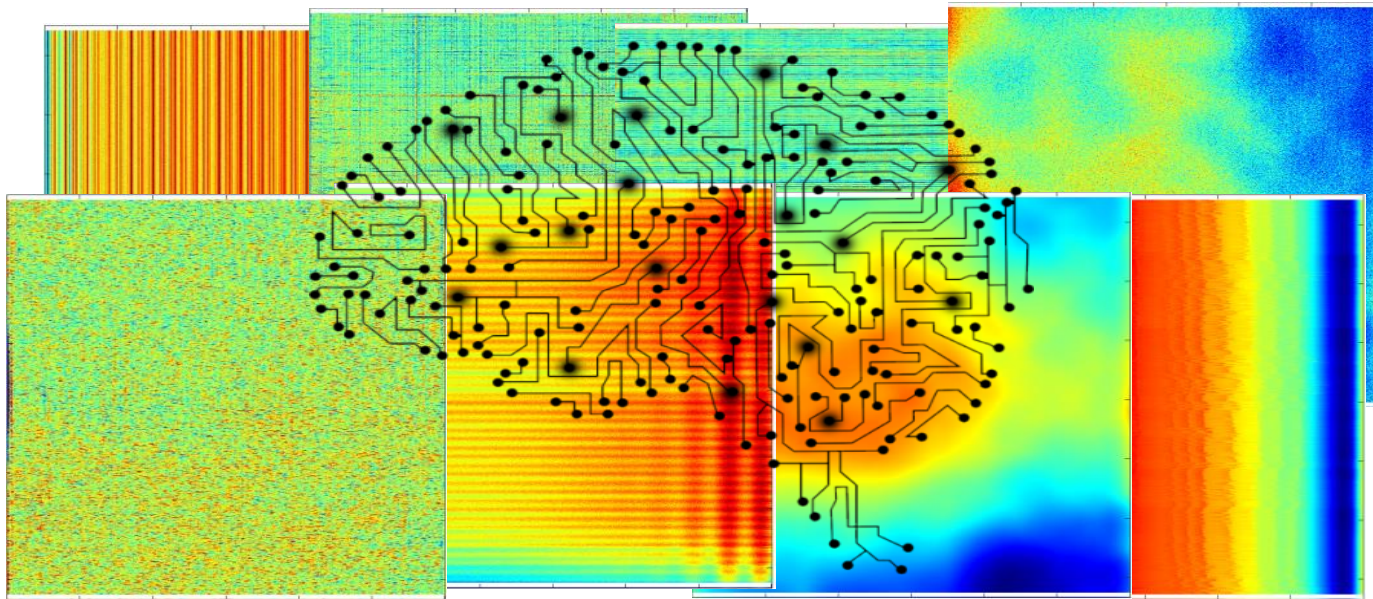
Writer Servo Log Statistical Analysis

		Strip to Strip Amplitude Diff			Strip Relative Dynamics	Flyer Data
		σX	σY	FFT		
X	XsDev:	●	●	●	●	●
	XsOut:	●	●	●	●	●
	XIPos-XsPos HP:	●	●	●	●	●
Y	YsDev:	●	●	●	●	●
	YsOut:	●	●	●	●	●
	YIDev:	●	●	●	●	●
Z	YIPos-YsPos HP:	●	●	●	●	●
	ZsPos HP:	●	●	●	●	●
	ZsDev:	●	●	●	●	●
F	ZsOut:	●	●	●	●	●
	FsDev:	●	●	●	●	●
	FsOut:	●	●	●	●	●
	FlowA:	●	●	●	●	●
	FlowB:	●	●	●	●	●
	RefA:	●	●	●	●	●
DOE	RefB:	●	●	●	●	●
	DoeDev:	●	●	●	●	●
	DoeOut:	●	●	●	●	●

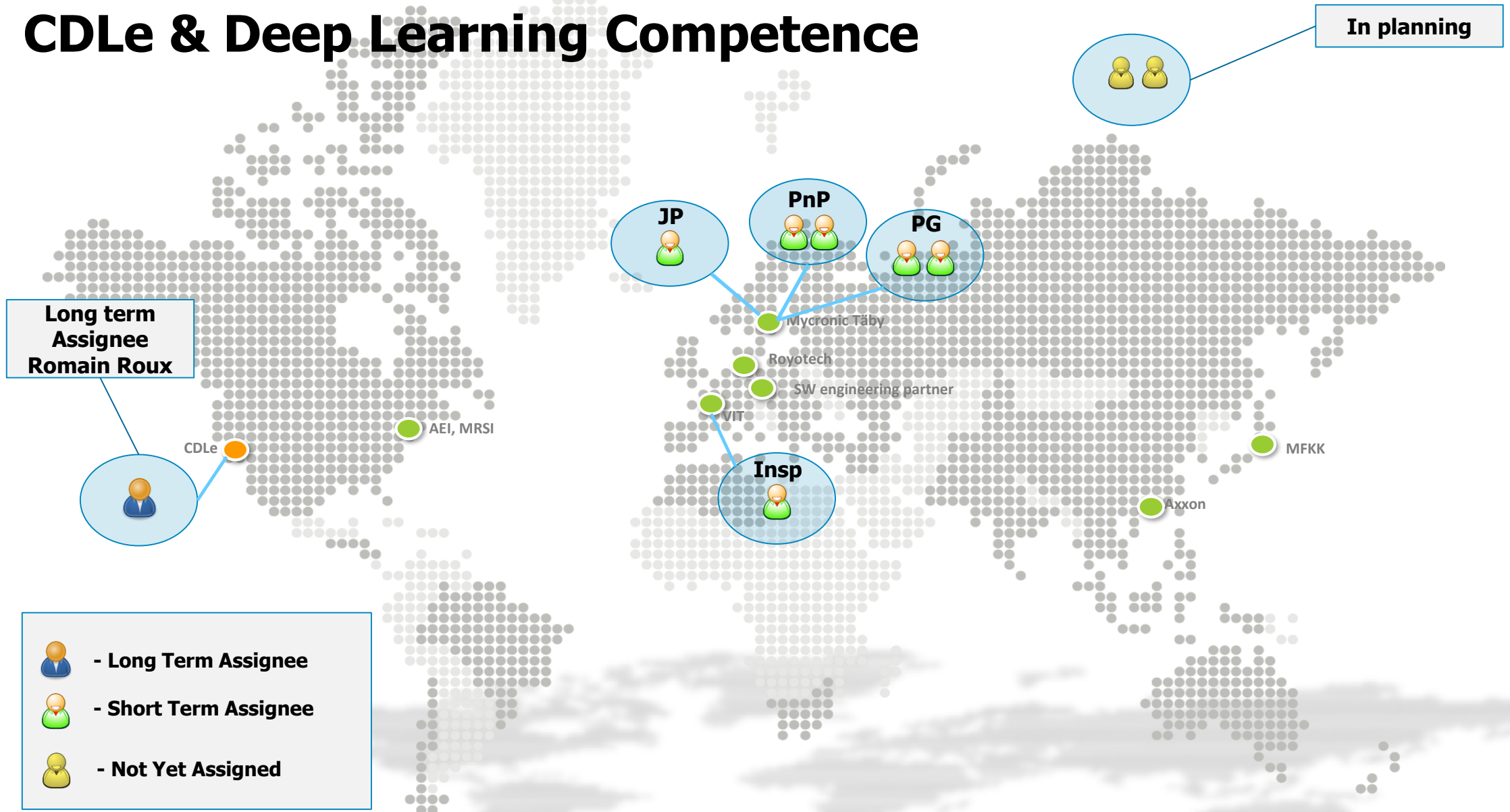
FFT of Strip Data



Deep Learning

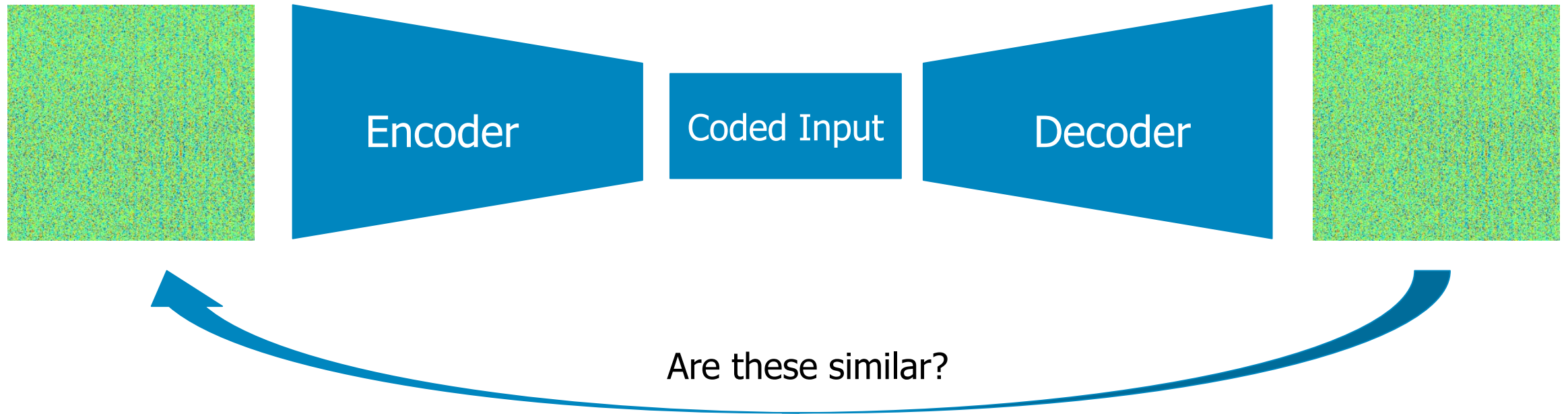


CDLe & Deep Learning Competence



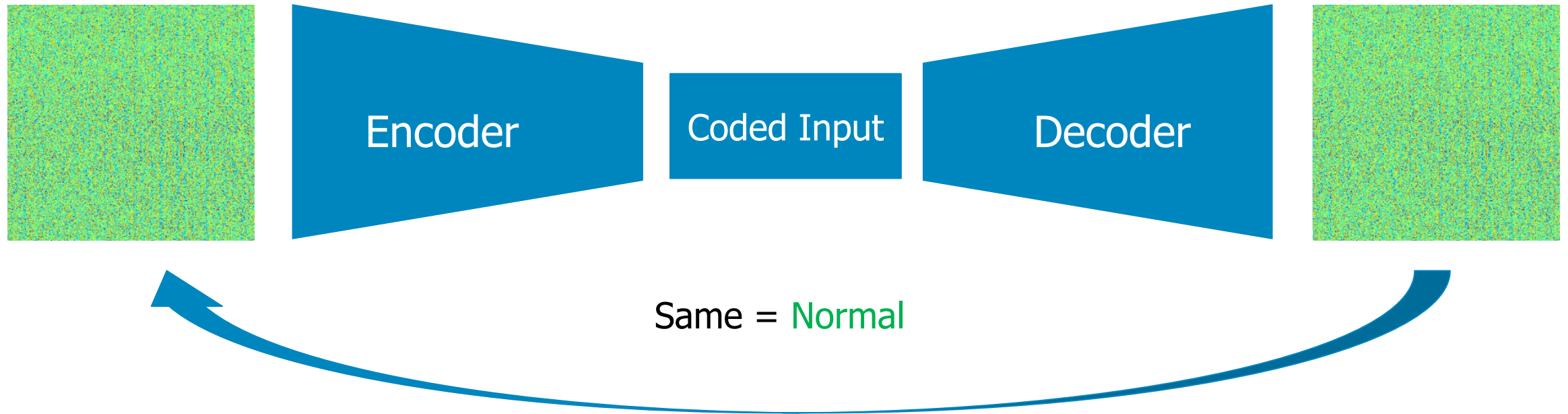
Anomaly Detection Using Autoencoders

Capturing Normal Behavior



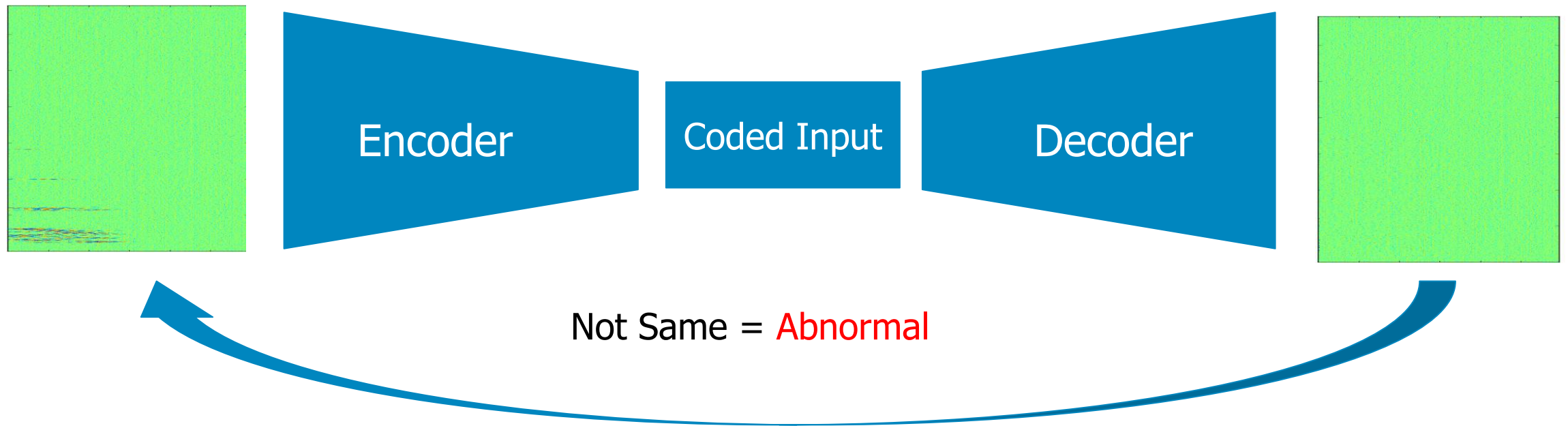
Anomaly Detection Using Autoencoders

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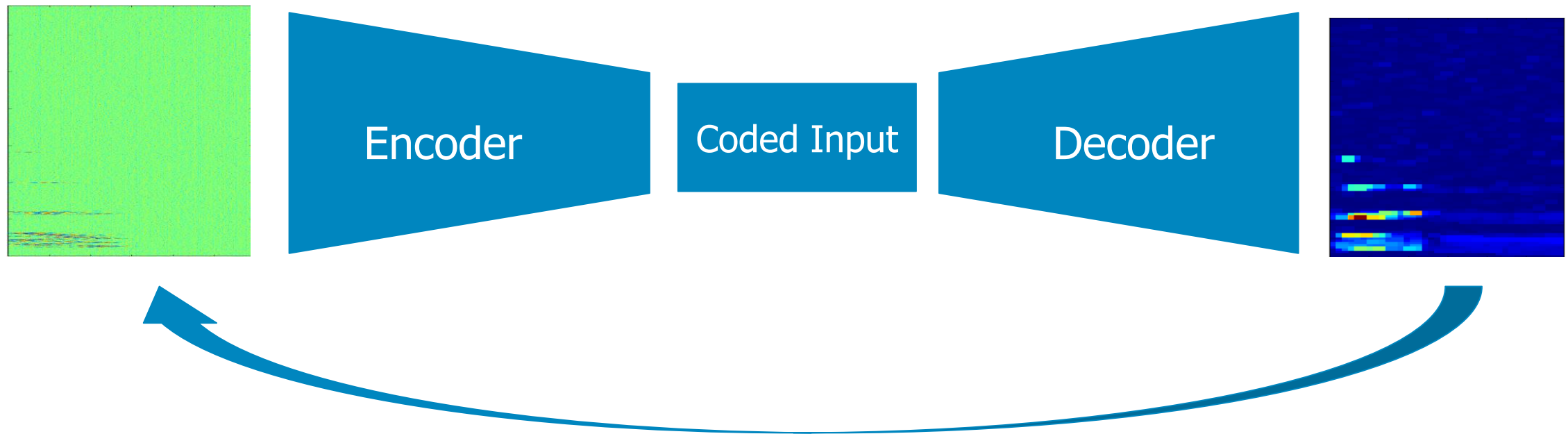
Anomaly Detection Using Autoencoders

Capturing Abnormal Behavior



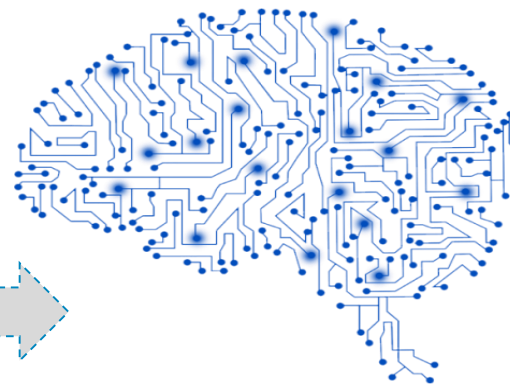
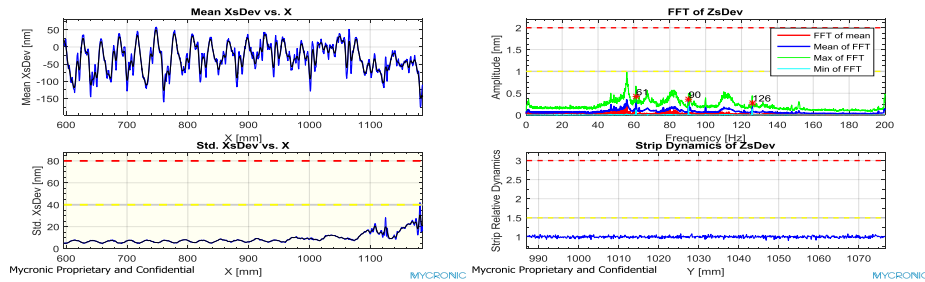
Anomaly Detection Using Autoencoders

Capturing Abnormal Behavior



Using the Available Data Efficiently

Deep Learning opens up new possibilities



Preventive & Predictive maintenance

Improved Quality control

Generate ideas for improvements

Step 1: Collect data

- Mask writer log data
- Potentially also mask quality data

Step 2: Analyze data

- Statistical methods
- Deep Learning

Step 3: Turn data into valuable insights

Thank You!